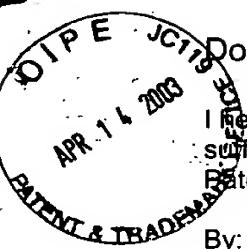


1763



Docket No.: P2000,0145

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By: Markus Nolff

Date: April 9, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor : Anne Kurtenbach et al.  
 Appl. No. : 09/923,701  
 Filed : August 6, 2001  
 Title : Apparatus and Method for Removing an Organic Material from a Semiconductor Device  
 Examiner : Parviz Hassanzadeh - Art Unit: 1763

R E S P O N S E

Hon. Commissioner of Patents and Trademarks,  
 Washington, D. C. 20231

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**TC 1700**

Sir:

Responsive to the Office Action dated March 17, 2003, the following remarks are made:

In deference to the restriction requirement on pages 2 and 3 of the above-identified Office Action, applicants elect group II, claims 10-20, for prosecution at this time.

Applicants reserve the right to file a divisional application including the device claims of group I at a later date.

In view of the foregoing, the early issuance of an Action on the merits of claims is solicited.

Respectfully submitted,

Markus Nolff  
 For Applicants

Markus Nolff  
 Reg. No. 37,006

Date: April 9, 2003

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